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Dated: March 29, 2005

Signature:

(Michael R. Hull)

Docket No.: 30205/39380
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Jong Goo Jung et al.

Application No.: 10/603,976

Confirmation No.: 3741

Filed: June 25, 2003

Art Unit: 2813

For: CMP SLURRY COMPOSITION FOR OXIDE FILMS AND METHODS FOR FORMING METAL LINE CONTACT PLUGS USING THE SAME

Examiner: Stephen W. Smoot

AMENDMENT AFTER FINAL ACTION (37.C.F.R. SECTION 1.116)

Do
Not
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MS AF
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Dear Sir:

INTRODUCTORY COMMENTS

In response to the final office action dated January 6, 2005, please amend the above-identified U.S. patent application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 5 of this paper.

8.W.S.
4-11-05